

UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/944,947	09/01/2001	Wu-Niang Feng	1641008	2762
	590 11/24/2004		EXAM	INER
Keith Kline PRO-TECHTOR INTERNATIONAL SERVICES 20775 Norada Court			DUONG, THANH P	
			ART UNIT	PAPER NUMBER
Saratoga, CA 95070-3018			1764	

DATE MAILED: 11/24/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)
Office Action Summary	09/944,947	FENG, WU-NIANG
ome Action Summary	Examiner	Art Unit
The MAILING DATE	Tom P Duong	1764
The MAILING DATE of this communicated for Reply	ation appears on the cover sheet w	ith the correspondence address
A SHORTENED STATUTORY PERIOD FOR THE MAILING DATE OF THIS COMMUNICA Extensions of time may be available under the provisions of 3 after SIX (6) MONTHS from the mailing date of this communication of the period for reply specified above is less than thirty (30) do if NO period for reply is specified above, the maximum statute failure to reply within the set or extended period for reply will, Any reply received by the Office later than three months after earned patent term adjustment. See 37 CFR 1.704(b). Status 1) Responsive to communication(s) filed of 2a) This action is FINAL. 2b)[3] 3) Since this application is in condition for closed in accordance with the practice of closed in accordance with the practice of closed in accordance closed in the application of Claims 4) Claim(s) 10-15 is/are pending in the application is in claim(s) is/are with a claim(s) is/are allowed. Claim(s) 10-15 is/are rejected.	37 CFR 1.136(a). In no event, however, may a recation. ays, a reply within the statutory minimum of thirt by period will apply and will expire SIX (6) MON by statute, cause the application to become AB the mailing date of this communication, even if the mailing date of this communication. This action is non-final. allowance except for formal matter ander Ex parte Quayle, 1935 C.D.	reply be timely filed by (30) days will be considered timely. THS from the mailing date of this communication ANDONED (35 U.S.C. § 133). Simely filed, may reduce any
7) Claim(s) is/are objected to		
8) Claim(s) are subject to restriction	and/or election requirement	
oplication Papers	4 - 4 - 11011(,	
9) The specification is objected to by the Exa 10) The drawing(s) filed on is/are: a) Applicant may not request that any objection to Replacement drawing sheet(s) including the continuous three continuous three continuous transfer of the continuous transfer	accepted or b) objected to by to the drawing(s) be held in abeyance	e. See 37 CFR 1.85(a).
 12) Acknowledgment is made of a claim for for a) All b) Some * c) None of: 1. Certified copies of the priority docur 2. Certified copies of the priority docur 3. Copies of the certified copies of the application from the International But * See the attached detailed Office action for a 	ments have been received. ments have been received in Appl priority documents have been rec	ication No ceived in this National Stage
	, 12.1131100	
chment(s)		
Notice of References Cited (PTO-892)	_	
TO THE PROPERTY OF THE PROPERT	4) 🔲 Interview Summ	nary (PTO_413)
Notice of Neferences Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449 or PTO/SB Paper No(s)/Mail Date	/ Paper No(s)/Ma	il Date lal Patent Application (PTO-152)

Art Unit: 1764

DETAILED ACTION

Applicants' remarks and amendments filed on September 17, 2004 have been carefully considered. Claims 1-9 have been canceled. New claims 10-15 have been added. Claims 10-15 are pending in this application.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 1. Claims 10 and 14-15 are rejected under 35 U.S.C. 103(a) as being unpatentable over Bartz (5,603,905) in view of Haldeman (2,545,028) and Kleeberg et al. (4,304, 570). Bartz discloses a semiconductor waste-gas treating apparatus (Fig. 3) having the ability of preventing sedimentation and etching of filth (Col. 5, lines 38-40), said apparatus comprises a header (steel plate 41 supporting tubes 42 and 44) and a waste gas treating trough (51) mounted below said header and having at the center thereof a reaction room (31), and is characterized by: said reaction room is surrounded by a water receiving chamber outside (51) of it, said water receiving chamber is provided on the top thereof with an annular spillway (wall between 50 and 51) in communicating with said reaction room (31), water in said smoothly and uniformly distributed to said water

Art Unit: 1764

receiving chamber is annular spillway, and spills to said reaction room to form an annular water wall on the wall of said reaction room; and a water receiving chamber 51 with a water inlet (52) and water discharge outlet (55). Bartz '905 fails to disclose annular guide in which said waste gas treating trough is mounted below said header. Haldeman teaches the annular guide (centrally disposed tube 16) located interior of the cylinder 2. The tube 16 facilitates the movement of the fluid in a circular path, which increases the fluid net velocity (Col. 5, lines 17-25). Thus, it would have been obvious in view of Haldeman to one having ordinary skill in the art to modify the waste gas apparatus of Bartz with an annular guide as taught by Haldeman in order to increase the velocity of the water moving downstream, which aids in cleaning and/or prevent the deposition of particulates on the inner wall. Bartz '950 also fails to disclose a sensing probe in the annular spillway to detect the water level in the water receiving chamber. Kleeberg teaches the a sensing probe (level sensor 22) mounted in the chamber 8 to detect the liquid scrubbing level in the vessel. Thus, it would have been obvious in view of Kleeberg to one having ordinary skill in the art to modify the waste gas apparatus of Bartz with the sensing probe as taught by Kleeberg to detect the scrubbing liquid level in the reaction chamber. Regarding claim 14, Bartz discloses a annular spillway (wall between 50 and 51) with no sensing probe. Regarding claim 15, Bartz fails to disclose the annular guide is provided on the top with annular flange. Haldeman teaches the annular guide (centrally disposed tube 16) is threaded to the top flange (plate 14) and the annular guide (tube 16) is supported by the top flange (plate 14). Thus, it would have been

Art Unit: 1764

obvious in view of Haldeman to one having ordinary skill in the art to modify the waste gas apparatus of Bartz with an annular guide with supporting top flange as taught by Haldeman in order to provide supporting structure for the annular guide.

- 2. Claim 11 is rejected under 35 U.S.C. 103(a) as being unpatentable over the applied references as applied to claim 10, above, and further in view of Shular (3,881,874). The applied references fails to disclose a header is provided with a sensing probe to sense the reaction temperature in the reaction room. Shular teaches the temperature sensing probes 40-43 are located in the combustion chambers H and I to measure the temperature of the reaction. Thus, it would have been obvious in view of Shular to one having ordinary skill in the art to modify the waste gas apparatus of the applied references with sensing probes as taught by Shular in order to provide means for measuring the temperature in the gas chamber.
- 3. Claims 12-13 are rejected under 35 U.S.C. 103(a) as being unpatentable over the applied references as applied to claim 11, above, and further in view of Suttrop (6,267,585). The applied references in claim 11 disclose the claimed invention except a plurality of hydrogen spraying nozzle with a fire spraying port. Suttrop teaches it is conventional to provide hydrogen injection nozzles with vortex spraying mechanism and such configuration maximizes the flame area or burning surface area in the combustion chamber (Col. 2, lines 26-44). Thus, it

Art Unit: 1764

would have been obvious in view of Suttrop to one having ordinary skill in the art to modify the waste gas apparatus of the applied references with a hydrogen spraying nozzles as taught by Suttrop in order to maximize the burning area in the combustion chamber.

Response to Arguments

Applicant's arguments with respect to claims 1-9 have been considered but are moot in view of the new ground(s) of rejection.

Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Art Unit: 1764

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Tom P Duong whose telephone number is (571) 272-2794. The examiner can normally be reached on 8:00AM - 4:30PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Glenn Caldarola can be reached on (571) 272-1444. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Tom Duong November 15, 2004

70

Glenn Caldarola Supervisory Patent Examiner Technology Center 1700